



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 10, 2026	
IGI Report Number	LG807650734
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.38 - 7.41 X 4.69 MM

GRADING RESULTS

Carat Weight	1.59 CARAT
Color Grade	F
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

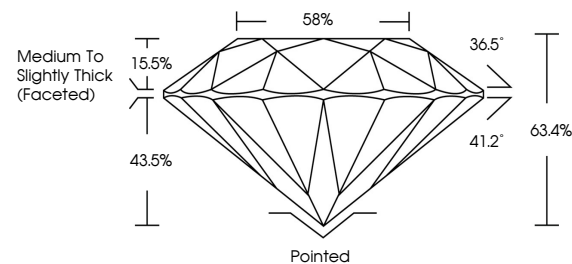
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	13 LG807650734

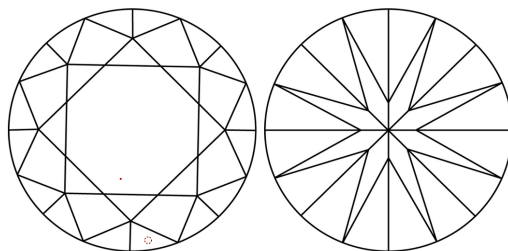
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG807650734
Report verification at igi.org

PROPORTIONS

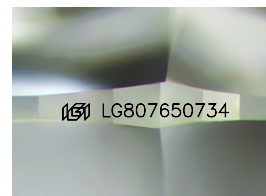


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

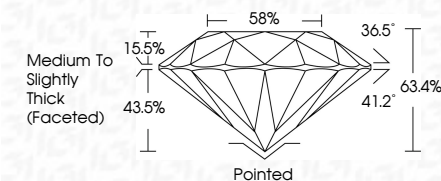
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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www.igi.org

June 10, 2026	1.59 CARAT
GI Report No. LG807650734	F VS 2
ROUND BRILLIANT	EXCELLENT
	63.4%
	59%
	Medium to Slightly Thick (scored)
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	#69 LG907650734
	Comments:
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	Type IIA